

Docket No.: 21806-00157-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Robert T. Froebel et al.

Application No.: 10/707,864

Confirmation No.: 1863

Filed: January 19, 2004

Art Unit: 2877

For: ALIGNMENT MARK SYSTEM AND  
METHOD TO IMPROVE WAFER  
ALIGNMENT SEARCH RANGE

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Examiner: Akanbi, Iiaka

**AMENDMENT**

**MS Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed February 9, 2006, please amend the above-identified U.S. patent application as follows:

**LISTING OF THE CLAIMS** begin on page 2.

**REMARKS** begin on page 7.